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Inventor: Garry A. Mercaldi  
Title: Low Selectivity Deposition Methods  
Assignee: Micron Technology, Inc.  
Serial No.: 09/643,004  
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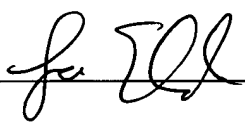
**INFORMATION DISCLOSURE STATEMENT**  
**PURSUANT TO 37 C.F.R. §§1.56, 1.97 AND 1.98**

In compliance with 37 C.F.R. §§1.56, 1.97 and 1.98, your attention is directed to the U.S. Patents and other documents listed on the attached Form PTO-1449, and copies of which are attached. No admission is made regarding whether the submitted references are prior art.

Citation of these references is respectfully requested.

Respectfully submitted,

Dated: 20 Mar 2003

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